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**PATENT**  
Attorney Docket No. MIT-166  
(058420/157388)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT:           Liu *et al.*  
SERIAL NO.:           10/566,686           GROUP NO.:           1784  
FILING DATE:        March 8, 2007       EXAMINER:           J. Langman  
TITLE:                METHOD AND STRUCTURE OF STRAIN CONTROL OF SIGE  
                          BASED PHOTODETECTORS AND MODULATORS

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

This paper is responsive to the final Office action mailed on November 12, 2010, in the above-identified patent application.

Please consider following:

**Remarks** begin on page 2 of this paper.